

FIG.1

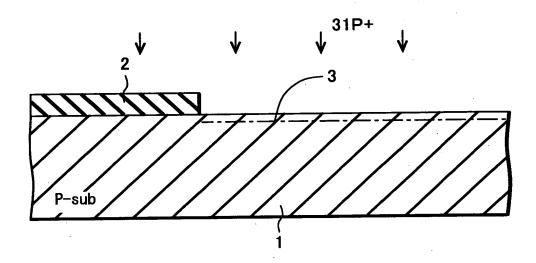
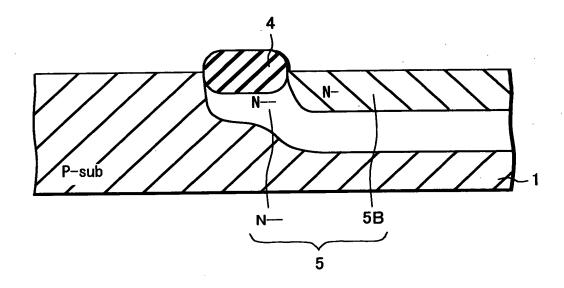


FIG.2



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FIG.3

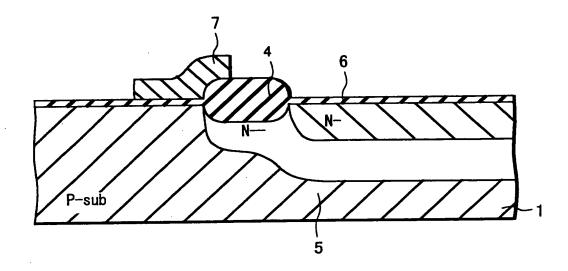
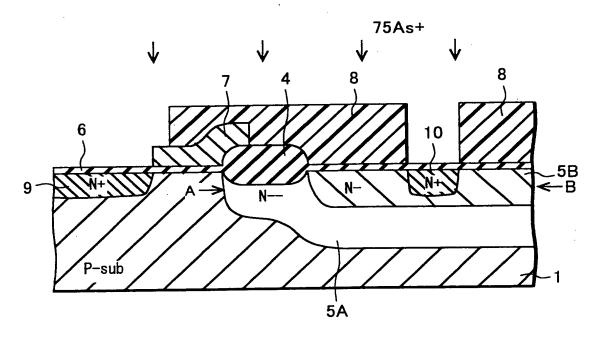


FIG.4



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FIG.5

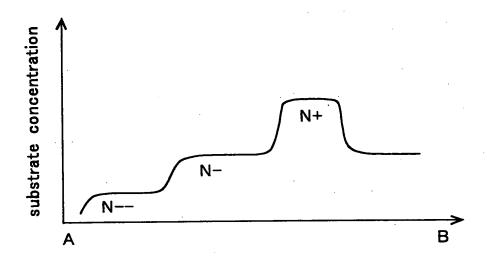


FIG.7

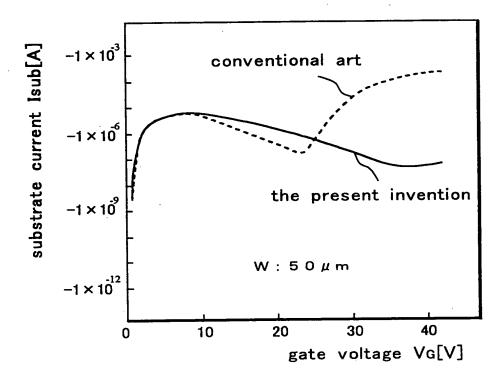
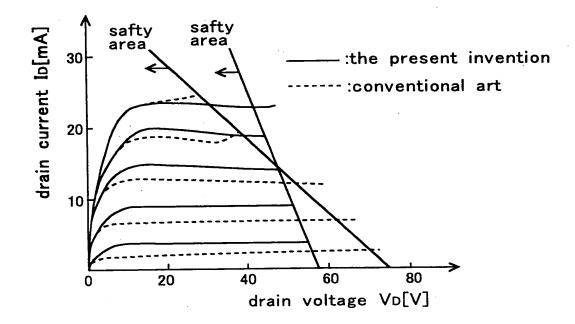


FIG.8



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FIG.9

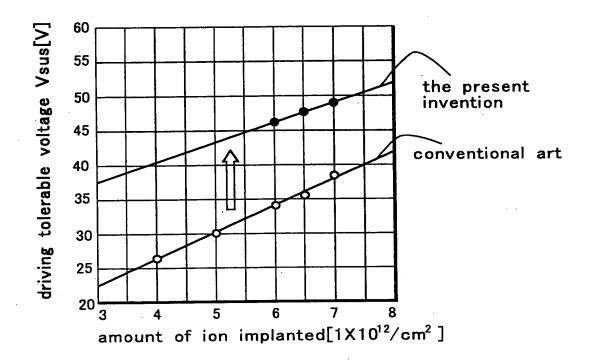


FIG.10

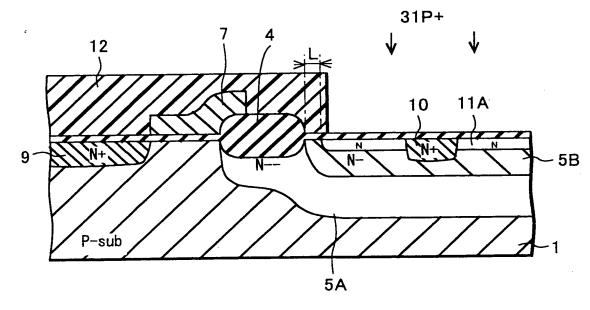


FIG.11

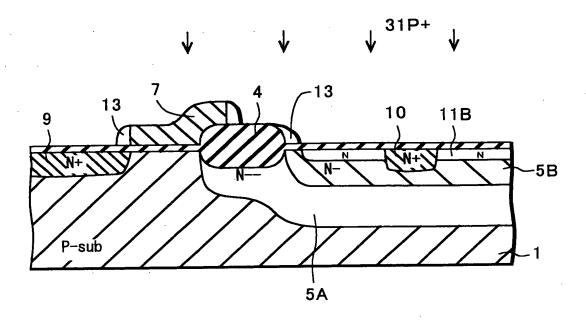
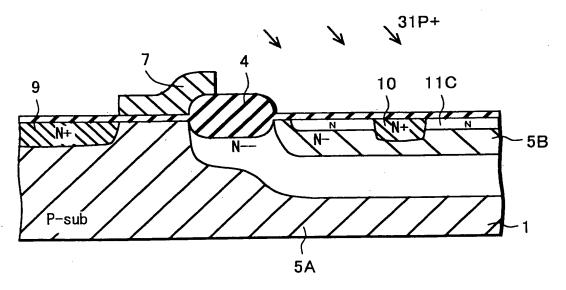


FIG.12



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FIG.13 (PRIOR ART)

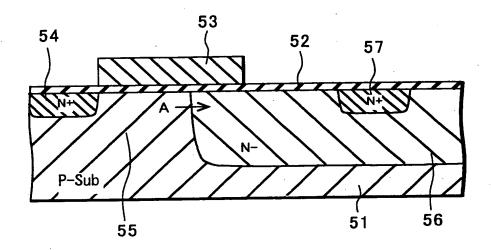
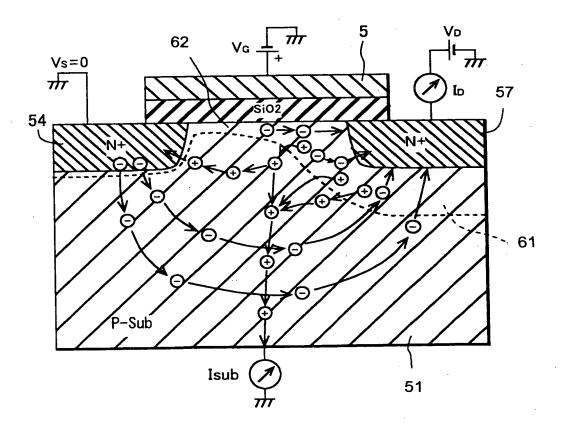


FIG.14 (PRIOR ART)



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FIG.15 (PRIOR ART)

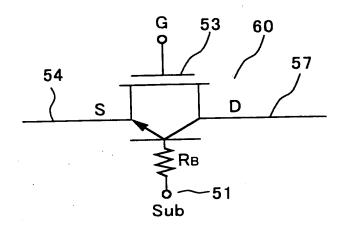


FIG.16 (PRIOR ART)

